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CONFIRMATION NO. 9990

SERIAL NUMBER 10/506,457	FILING OR 371(c) DATE 01/05/2005 RULE	CLASS 216	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 10191/3935
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APPLICANTS

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**** CONTINUING DATA *******

This application is a 371 of PCT/DE03/00676 03/05/2003

**** FOREIGN APPLICATIONS *******

GERMANY 102 09 763.1 03/05/2003
 GERMANY 102 49 350.2 10/23/2002

Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY GERMANY	SHEETS DRAWING 9	TOTAL CLAIMS 18	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

ADDRESS

26646

TITLE

Device and method for anisotropically plasma etching of a substrate, particularly a silicon body

FILING FEE RECEIVED 1050	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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